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ABSTRACT OF THE DISCLOSURE

An integrated mask including a plurality of deposition masks, each deposition mask having an array of deposition apertures formed in accordance with a deposition pattern; and a base plate having a plurality of openings on which the deposition masks are arranged is provided. The deposition masks are retained to the base plate by engaging units in a disengageable manner, and alignment marks used for positioning the deposition masks on the base plate are formed on the base plate. In addition, a method and apparatus for fabricating the integrated mask, a method and apparatus for manufacturing an organic EL device using the integrated mask, and an organic EL device are provided.